Direct observation of a widely tunable bandgap in bilayer graphene

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Bandgap

- >determines transport and optical properties of insulators and semiconductors.
- >It governs the operation of devices such as p-n junctions, transsitors, photo diods and lasers.
- >If tunable allows flexibility in design an optimization of devices
- >Conventional determined by the crystal structure no control over band gap

Graphene

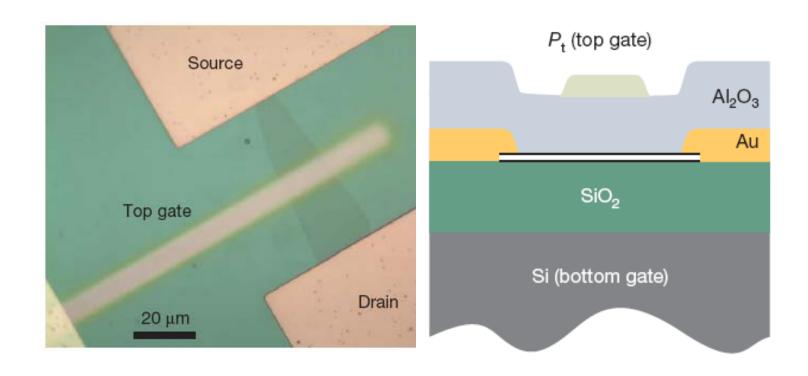
- >Having no bandgap greatly limits graphene's uses in electronics.
- > Can build FETs but CANT turn them OFF with ZERO band gap
- >Non zero bandgap good transistors, nano LEDs and nanooptical devices in IR region.
- >Observation of non zero bandgap in bilayer graphene in which one of the layers were chemically doped
- > Chemical doping uncontrolled, not compatible with device application

Present

- >Bilayer graphene tuning the band gap electrical doping
- >Appliation of perpendicular electric field continuous tuning
- > Single gated bilayer graphene FETs require refrigeration ~ 1K
- >built a two-gated bilayer device, fabricated by Yuanbo Zhang and Tsung-Ta Tang of the UC Berkeley Department of Physics, which allowed the team to independently adjust the electronic bandgap and the charge doping
- >Room temperature continuously tunable bandgap upto 250 meV

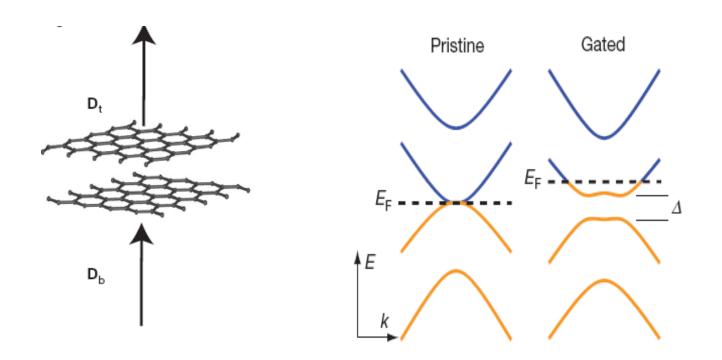
Device

- > Dual-gated field-effect transistor (FET), a type of transistor that controls the flow of electrons from a source to a drain with electric fields shaped by the gate electrodes.
- Nano-FET used a silicon substrate as the bottom gate, with a thin insulating layer of silicon dioxide between it and the stacked graphene layers.
- > A transparent layer of aluminum oxide (sapphire) lay over the graphene bilayer; on top of that was the **top gate**, made of **platinum**



Optical Image

Schematic



produce two effects,

 δ = Db -Dt, leads to a net carrier doping, that is, a shift of the Fermi energy (EF).

D = (Db+Dt)/2, breaks the inversion symmetry of the bilayer and generates a non-zero bandgap.

By setting d = 0, and varying D, we can tune the bandgap while keeping the bilayercharge neutral (CNPs).

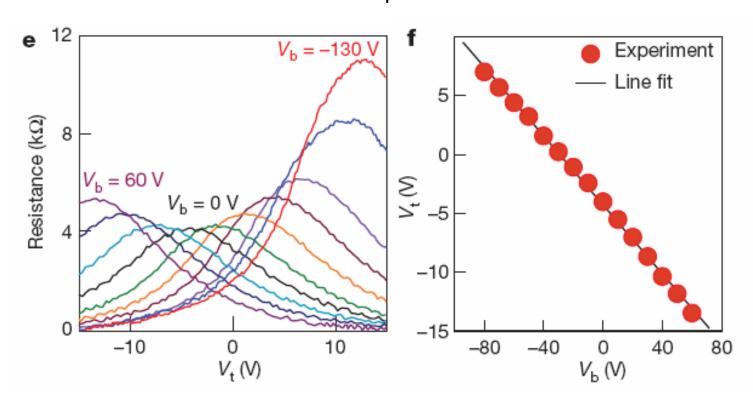
By varying d keeping D constant we can shift the Fermi level by injecting either holes or electrons without altering the band gap

Drain is grounded - the displacement fields are controlled by top and bottom gates alone

$$D_b = \varepsilon_b (V_b - V_b^0)/d_b$$

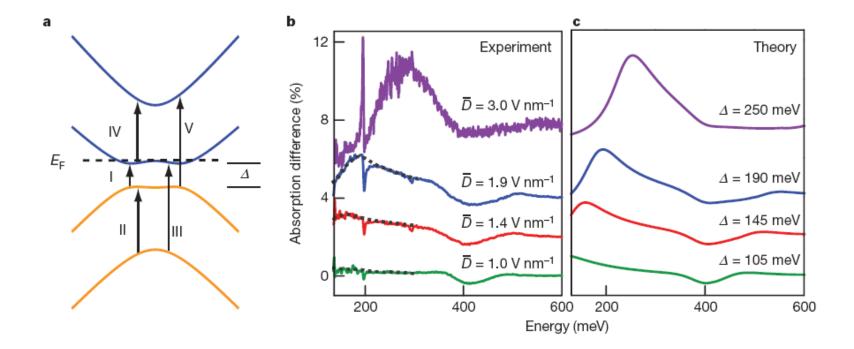
$$Dt = \varepsilon_t (V_t - V_t^0)/d_t$$

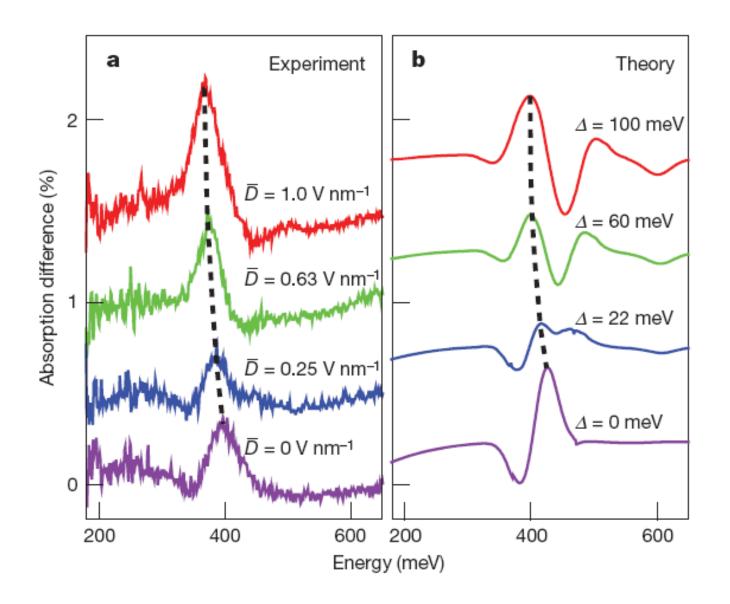
Eelctrical transport measurements

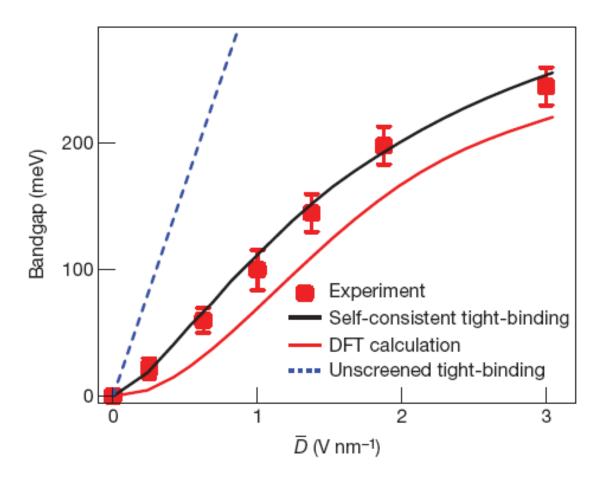


Instead of electrical resistance/transport, they choose to measure optical transmission - Advansed Light source, LBNL

- > Transport measurements are too sensitive to defects
 A tiny amount of impurity or defect doping can create a big change in
 the resistance of the graphene and mask the intrinsic behavior of the
 material.
- > Using infrared beamline 1.4 at the ALS, they were able to send a tight beam of synchrotron light, focused on the graphene layers, right through the device. Beam very bright, could focus down to the diffraction limit.
- > by tunig the electric field by precisely varying voltage of the GATE electrodes, measured the variation in light absorbed
- > Absorption peak in each measurement gives the direct bandgap at each GATE voltage







Thank You

Robin John PH08D023